

APPLICANT'S ART CITATION

Application 10/585,289

ORFS File No. P/2850-144

Applicant Takeshi Nakamura

Filing Date

July 7, 2006

Group Art Unit

1755

U.S. PATENT DOCUMENTS (not submitted for applications filed after 6/30/03)

	Document Number	Date MM-YYYY	Name	Class	Sub- class	Filing Date If Appropriate
/CT/	US-6,838,162 B1	01-2005	GRUBER ET AL.			
/CT/	US-2003/0008067 A1	01-2003	YAMAGUCHI ET AL.			
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					
	US-					

FOREIGN PATENT DOCUMENTS

	Document Number	Date MM-YYYY	Country	Class	Sub- class	Translation	
						Yes	No
/CT/	CN 1288874	09-2000	CHINA			U.S.P 6,838,162	
/CT/	JP 2003-20287	01-2003	JAPAN			U.S. PUB. 2003/0008067	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/CT/	Office Action issued November 30, 2007 in corresponding Chinese Application No. 200480039952.9 and an English translation

Examiner

/Camie Thompson/

Date Considered

04/07/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.